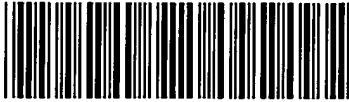


Search Notes

Application No.

10/673,209

Examiner

Rodney E Fuller

Applicant(s)

LATYPOV ET AL.

Art Unit

2851

SEARCHED

Class	Subclass	Date	Examiner
355	53 67 71	1/26/2005	REF

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East: maskless lithography + overlapping + stitching + pixels + on + off + pairs + alternating + pattern	1/26/2005	REF